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October 12, 2004

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Commissioner for Patents To:

Atm: Responses to Office Actions

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Alexandria, VA 22313-1450

From: Pamela J. Squyres Attorney Docket: MA-027

Phone: 408-869-2921

FAX NUMBER 703-872-9306

Re: Patent Application of: Michael A. Vyvoda et al.	Examiner: Anh D. Mai
Serial No.: 09/776,009	Group Art Unit: 2814
Filed: February 2, 2001	Attorney Docket No.: MA-027
Title: Wafer Surface that Facilitates Particle	
Removal	

Document(s) Transmitted:

□ Amendment and Response to Non-Final Office Action (7 pages)

Total pages of this transmission, including the cover letter: 8 If you do not receive all of the pages described above, please telephone us at 408-869-2921 or fax us at 408-969-4849.

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> Parnela J. Squyres 27 Date of Transmission

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814

Examiner: Anh D. Mai

Applicant(s): Vyvoda et al.

Application No.: 09/776009

Filed: 02/02/2001

Title: Wafer Surface that Facilitates Particle

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Attorney Docket No.: MA-027

Assistant Commissioner for Patents

PO Box 1450

Alexandria VA 22313-1450

October 12, 2004

To the Commissioner:

AMENDMENT AND RESPONSE TO NON-FINAL OFFICE ACTION

Please enter the following in response to the non-final Office Action of July 14, 2004, in the above-captioned application. A complete list of pending claims begins on page 2. Remarks begin on page 4. A Conclusion appears on page 7.

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09/776009

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